

00684.003077.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiroki SUZUKAWA

Application No.: 09/668,064

Filed: September 25, 2000

For: EXPOSURE METHOD AND  
EXPOSURE APPARATUS

Examiner: P. Kim

Group Art Unit: 2851

August 5, 2002  
(Monday)

The Commissioner for Patents  
Washington, D.C. 20231

#8/1  
1-29-03  
JLR

TECHNOLOGY CENTER 2800

AUG - 8 2002

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AMENDMENT WITH PETITION FOR EXTENSION OF TIME

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated April 3, 2002, for one month from July 3, 2002, to Monday, August 5, 2002. A check in the amount of \$110.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

In response to the Official Action dated April 3, 2002, please amend the above-identified application as follows:

08/07/2002 NM0HMM1 00000059 09668064

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110.00 OP

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